
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Koos et al.

Attorney Docket No.:
NOVLP068/NVLS-2818

Application No.: 10/690,084

Examiner: Vinh, Lan

Filed: October 20, 2003

Group: 1765

Title: METHOD FOR FABRICATION OF
SEMICONDUCTOR INTERCONNECT
STRUCTURE WITH REDUCED CAPACITANCE,
LEAKAGE CURRENT, AND IMPROVED
BREAKDOWN VOLTAGE

Confirmation No.: 4873

CERTIFICATE OF FACSIMILE TRANSMISSIONI hereby certify that this correspondence is being transmitted by facsimile to fax
number 571-273-8300 to the U.S. Patent and Trademark Office. Attention
Examiner Lan Vinh on August 28, 2007.Signed: 

Mary Terry

INFORMATION DISCLOSURE STATEMENT
37 CFR §§1.56 AND 1.97(b)Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

The reference(s) identified in the attached PTO Form 1449 (copies of non-U.S. references are attached) may be material to examination of the above-identified patent application. Applicants identify these reference(s) in compliance with their duty of disclosure pursuant to 37 CFR §§1.56 and 1.97. The Examiner is requested to make the identified reference(s) of official record in this application.

This Information Disclosure Statement is not to be construed as a representation that a search has been made, that additional information material to the examination of this application does not exist, or that the identified reference(s) indeed constitute prior art.

This Information Disclosure Statement is being filed after the mailing date of the first Office Action on the merits, or after three months from the filing date of this application, whichever event occurred last, but it is believed before the mailing date of either: (i) a final action under §1.113 or (ii) a notice of allowance under §1.311, whichever occurs first.

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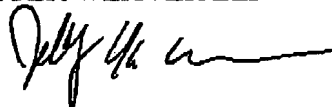
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Accompanying this Information Disclosure Statement is the fee set forth in 37 CFR
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☒ The Commissioner is authorized to charge \$180.00 in payment of the Information
Disclosure Statement Fee. If it is determined that any additional fees are due, the Commissioner
is hereby authorized to charge such fees to Deposit Account 500388 (Order No. NOVLP068).

Respectfully submitted,
BEYER WEAVER LLP



Jeffrey K. Weaver
Reg. No. 31,314



Anna Gavrilova
Reg. No. 58,181

P.O. Box 70250
Oakland, CA 94612-0250

Docket No.: NOVLP068/NVLS-2818

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Form 1449 (Modified) Information Disclosure Statement By Applicant (Use Several Sheets if Necessary)	Atty Docket No.	Application No.:
	NOVLP068/NVLS-2818	10/690,084
	Applicant:	
	Koos et al.	
	Filing Date	Group
	October 20, 2003	1765

U.S. Patent and Publication Documents

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub-class	Filing Date
	A1	7,049,234	05/2006	Cheng et al.			
	A2	2005/026625	12/2005	Cheng et al.			
	A3	2003/0190426	10/2003	Padhi et al.			
	A4	2003/0059526	10/2003	Chung et al.			
	A5	2004/0253740	12/2004	Shalyt et al.			

Foreign Patent or Published Foreign Patent Application

Examiner Initial	No.	Document No.	Publication Date	Country or Patent Office	Class	Sub-class	Translation	
							Yes	No
	B1							

Other Documents

Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
	C1	
Examiner		Date Considered

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.